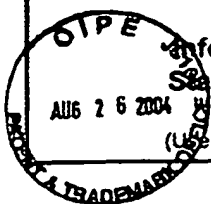


Form 1449 (Modified)



Information Disclosure Statement By Applicant

(Use Several Sheets If Necessary)

Attorney Docket No.

LAM2P468

U.S.

10/816,431

Applicant:

Anderson II, et al.

Filing Date:

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Group:

3723

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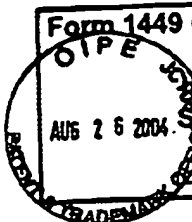
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Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
DVW	Q/	EP0920956	06/1999	EPO			x	
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	W	
	X	
	Y	
	Z	
Examiner Dung van Nguyen		Date Considered 12-3-2004

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 1449 (Modified) 	Information Disclosure Statement By Applicant		Atty Docket No:	U.S.
			LAM2P468	10/816,431
			Applicants:	
			Anderson II, et al.	
			Filing Date:	Group:
		March 31, 2004	3723	

(Use Several Sheets If Necessary)

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	O							
	P							
	Q							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
	S	
Examiner <i>Dring von Nguyen</i>		Date Considered 12-3-2004

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

* Listed on page 1